I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Amendment, Assistant Commissioner for Patents, Washington, D.C. 20231, on July 26,

12-00-102-1281/0 #10/8horaton / 8/21/96

Docket: 0756-

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of

Hongyong ZHANG et al.

Group Art Unit: 1104 Serial No. 08/462,742 Examiner Radomsky Filed: June 5, 1995

SEMICONDUCTOR DEVICE AND For:

FABRICATION METHOD OF THE

Date: July 36, 1996 **SAME**

Honorable Commissioner of Patents and Trademarks Washington, D.C. 20231

Sir:

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated as shown below:

	Claims Remaining After Amendment		Highest Number Previously Paid For	Present Extra	Rate Sm/Lg Entity	Fee
		Minus	22	1	X 11/22	\$22.00
Total	23	Willus	ļ	0	X 39/78	0.00
Indep.	11	Minus	11	10	1	
First presentation of multiple dependent claims						\$22.00

A check in the amount of \$22,00 to 60 years the additional claims [X]1 102 fee is enclosed.

Docket: 0756-1299

- [X] In the event applicant(s) has overlooked the need for any petition and fee for extension of time, and such extension is required, applicant(s) requests that this be considered a petition therefor and that such fee be charged to Deposit Account No. 19-2380.
- [X] The Commissioner is hereby authorized to charge fees under 37 CFR 1.16, 1.17, 1.20(a), 1.20(b), 1.20(c) and 1.20 (d) (except the Issue Fee) which may be required now or hereafter, or credit any overpayment, to Deposit Account No. 19-2380. A duplicate copy of this sheet is attached.

Respectfully submitted,

Bradley D. Blanche

Reg. No. 38,387

Sixbey, Friedman, Leedom & Ferguson, P.C.

2010 Corporate Ridge, Suite 600

McLean, Virginia 22102

(703) 790-9110

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Susan Y. Stiles

96 JUL 29 AM 11:01

#9/D Shoridon /8/21/96

Docket: 0756-1299

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of

Hongyong ZHANG et al.

Serial No. 08/462,742) Art Unit: 1104

Filed: June 5, 1995) Examiner: L. Radomsky

For: SEMICONDUCTOR DEVICE AND)

FABRICATION METHOD OF THE)

SAME) Date: July 26, 1996

AMENDMENT

Honorable Commissioner of Patents and Trademarks

Washington, D.C. 20231

Sir:

In response to the Official Action mailed April 26, 1996, please amend the above-identified application as follows:

In the Claims:

Please amend claims 3, 4-6, 20 and 21 as follows:

3. (Twice Amended) A method for fabricating a semiconductor device comprising:

forming [a substantially] an amorphous silicon film on a substrate;